



PATENT
Docket No.: Q106-US1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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GROUP 1700

In re Application of: :
Hisashi Tsukamoto et al. :
Application No.: 10/031,022 : Group Art Unit: 1734
Filing Date: January 14, 2002 : Examiner: N/A
Title: LITHIUM THIN FILM :
LAMINATION TECHNOLOGY :
ON ELECTRODE TO INCREASE :
BATTERY CAPACITY :

CERTIFICATE OF MAILING VIA EXPRESS MAIL (37 CFR 1.10)

Express Mail No.: EV160718202US

Dated April 23, 2003

Commissioner for Patents
Washington, D.C. 20231

I hereby certify that the following attached documents are being deposited with the United States Postal Service for "Express Mail Post Office to Addressee" service under 37 CFR 1.10 on the date indicated above and are addressed to Commissioner for Patents, Washington, D.C. 20231.

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